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033082M301

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Sumi TANAKAI, et al.

International Application No.: PCT/JP2004/011836

International Filing Date: August 18, 2004

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: SUBSTRATE HOLDING STRUCTURE AND SUBSTRATE  
PROCESSING APPARATUS

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists all of the documents noted in the International Search Report (ISR) filed herewith. On the PTO-1449, documents AA and AL are regarded as counterparts, per the ISR. Copies of the cited documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,  
SMITH, GAMBRELL & RUSSELL, LLP

By:



Michael A. Makuch, Reg. No. 32,263  
1850 M Street, N.W., Suite 800  
Washington, D.C. 20036  
Telephone: (202) 263-4300  
Fax: (202) 263-4329

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FORM PTO-1449  INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M301	SERIAL NO 3683 To Be Assigned
	APPLICANT: Sumi TANAKA, et al.	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

**U.S. PATENT DOCUMENTS**

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	2002/0170679	11/21/02	Yamaguchi, et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

**FOREIGN PATENT DOCUMENTS**

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO	
	AH	2000-21957	01/21/00	Japan			Abstract	
	AI	2003-224044	08/08/03	Japan			Abstract	
	AJ	11-354526	12/24/99	Japan			Abstract	
	AK	2003-60017	02/28/03	Japan			Abstract	
	AL	2002-373837	12/26/02	Japan			Abstract	
	AM							
	AN							
	AO							
	AP							

**OTHER INFORMATION** (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	
EXAMINER:		DATE CONSIDERED:
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>		